

<b>Notice of References Cited</b>	Application/Control No. 10/825,714		Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Tai Duong		Art Unit 2871	Page 1 of 1

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*	B	US-2002/0109811	08-2002	Park et al.	349/113
*	C	US-6,806,929	10-2004	Chen et al.	349/114
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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